To: USPTO

S/N

10/720,409

confirmation no. 5057

Applicant

Feng Chen

Response to Office Action dated 2006-09-25

Page]

Attorney Docket: C\$03-039

To:

Commissioner of Patents

P.O. Box 1450

Alexandria, VA 22313-1450

From:

William J. Stoffel

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Subject:

S/N

10/720,409

Inventor

Feng Chen

Confirmation no. 5057 Attorncy Docket: CS03-039

File date: 11/24/2003

Title: CMP Polishing Heads Retaining Ring Groove Design for Microscratch

Reduction

Group Art Unit: 3723

Examiner:

Shakeri

RESPONSE UNDER 37 CFR 1.116- EXPIDITED PROCEDURE EXAM GROUP 3723-

RESPONSE TO OFFICE ACTION DATED 2006-09-25

Dear Sir:

Enclosed is a Response to Office Action dated 2006-09-25.

Please consider the

following remarks:

CERTIFICATE OF MAILING OR FACSIMILE TRANSMISSION Total 28 Pages in this Fax

I hereby certify that this correspondence is being:

FAXED to the central facsimile number of patent and trademark office at the following number (571) 273-

[__] deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450; on the date below.

Signature /William J. Stoffel/

DATE November 27, 2006

William J. Stoffel

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